

12-20-2001



1 SHEET  
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U.S. DEPARTMENT OF COMMERCE  
Patent and Trademark Office

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101920382

To the Honorable Commissioner of Patents and Trademarks

the attached original documents or copy thereof.

1. Name of conveying party(ies):

Liji Huang, Naiqian Han, Yahong Yao,  
and Gaofeng Wang

11/12/01

2. Name and address of receiving party(ies):

Name: INTPAX, Inc.

Internal Address:

Street Address: 6 Results Way

City: Cupertino State: CA ZIP: 95014

Additional name(s) & address(es) attached? ☐ Yes ☒ No

Additional name(s) of conveying party(ies) attached? ☐ Yes ☒ No

3. Nature of conveyance:

- ☒ Assignment ☐ Merger  
☐ Security Agreement ☐ Change of Name  
☐ Other

Execution Date: November 8, 2001

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: November 8, 2001

A. Patent Application No.(s)

B. Patent No.(s)

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Bo-In Lin

Internal Address:

Street Address: 13445 Mandoli Drive

City: Los Altos Hills State: CA ZIP: 94022

6. Total number of applications and patents involved: One

7. Total fee (37 CFR 3.41): \$ 40.00

- ☒ Enclosed  
☐ Authorized to be charged to deposit account

8. Deposit account number:

(Attach duplicate copy of this page if paying by deposit account)

12/18/2001 LMUELLER 00000236 10011350

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9. Statement and signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Ching-lu Lin

Name of Person Signing

*Ching-lu Lin*

Signature

Nov. 12, 2001

Date

Total number of pages comprising cover sheet

Five

## ASSIGNMENT

Docket NO. INTPAX0101INVENTOR  
CITY

Whereas, I, Liji Huang of 2217 Ceynowa Lane,  
San Jose, California 95121,  
have invented:

TITLE:

**DEFINED SACRIFICIAL REGION VIA ION IMPLANTATION FOR  
MICRO-OPTO-ELECTRO-MECHANICAL SYSTEM (MOEMS)  
APPLICATIONS**

DATE INVENTOR  
SIGNED THE  
DECLARATION

and executed a United States patent application therefore  
on November 8, 2001 ;

Whereas, INTPAX, INC., having a place of business at Cupertino,  
California, (hereinafter called INTPAX), desires to acquire the entire right,  
title and interest of said application and invention, and to any United States  
and foreign patents to be obtained therefore;

Now therefore, for a valuable consideration, receipt whereof is hereby  
acknowledged, I, the above named, hereby sell, assign, and transfer to  
INTPAX, its successors and assigns, the entire right, title and interest in the  
said application and invention therein disclosed for the United States and  
foreign countries, and all rights of priority resulting from the filing said  
United States application, and I request the Commissioner of Patents to issue  
any Letters Patent granted upon the inventions set forth in said application to  
INTPAX its successors and assigns; and I hereby agree that INTPAX may  
apply for foreign Letters Patent on said invention and I will execute all papers  
necessary in connection with the United States and foreign applications when  
called upon to do so by

CITY AND  
DATE

Signed and Sealed at Cupertino, California  
on November 8, 2001 .

  
\_\_\_\_\_  
SIGNATURE OF INVENTOR

Docket NO. INTPAX0101

## ASSIGNMENT

INVENTOR  
CITY

Whereas, I, Nalqian Han of 6 Results Way,  
Cupertino, California 95014,  
have invented:

TITLE:

**DEFINED SACRIFICIAL REGION VIA ION IMPLANTATION FOR  
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necessary in connection with the United States and foreign applications when  
called upon to do so by

CITY AND  
DATE

Signed and Sealed at Cupertino, California  
on November 8, 2001.

  
SIGNATURE OF INVENTOR

## ASSIGNMENT

Docket NO. INTPAX0101INVENTOR  
CITY

Whereas, I, **Yahong Yao** of 18641 Crabtree Avenue,  
Cupertino, California 95014,  
have invented:

TITLE:

**DEFINED SACRIFICIAL REGION VIA ION IMPLANTATION FOR  
MICRO-OPTO-ELECTRO-MECHANICAL SYSTEM (MOEMS)  
APPLICATIONS**

DATE INVENTOR  
SIGNED THE  
DECLARATION

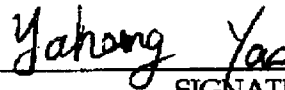
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called upon to do so by

CITY AND  
DATE

Signed and Sealed at Cupertino, California  
on November 8, 2001 .



SIGNATURE OF INVENTOR

Docket NO. INTPAX0101

## ASSIGNMENT

INVENTOR  
CITY

Whereas, I, Gaofeng Wang of 900 Henderson Avenue, #39  
Sunnyvale, California 94086,  
have invented:

TITLE:

**DEFINED SACRIFICIAL REGION VIA ION IMPLANTATION FOR  
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on November 8, 2001.

  
SIGNATURE OF INVENTOR